



(11) **EP 1 463 205 B8**

(12) **CORRECTED EUROPEAN PATENT SPECIFICATION**

(15) Correction information:
Corrected version no 1 (W1 B1)
Corrections, see
Bibliography INID code(s) 73

(51) Int Cl.:
H03M 3/02 ^(2006.01) **G01D 3/02** ^(2006.01)
G01D 5/12 ^(2006.01)

(48) Corrigendum issued on:
26.05.2010 Bulletin 2010/21

(45) Date of publication and mention
of the grant of the patent:
18.11.2009 Bulletin 2009/47

(21) Application number: **03447069.0**

(22) Date of filing: **28.03.2003**

(54) **Method and system for the indirect measurement of a physical value**

Verfahren und Vorrichtung zur indirekten Messung einer physikalischen Grösse

Méthode et appareil pour la mesure indirecte d'une grandeur physique

(84) Designated Contracting States:
DE FR

(43) Date of publication of application:
29.09.2004 Bulletin 2004/40

(73) Proprietor: **Semiconductor Components
Industries, LLC**
Phoenix, AZ 85008 (US)

(72) Inventors:
• **Horsky,Pavel**
63800 Brno (CZ)

• **Koudar,Ivan**
66451 Slapanice u Brna (CZ)

(74) Representative: **Bird, William Edward et al**
Bird Goën & Co.
Klein Dalenstraat 42A
3020 Winksele (BE)

(56) References cited:
EP-A- 1 102 405 US-A- 6 140 952

EP 1 463 205 B8

Note: Within nine months of the publication of the mention of the grant of the European patent in the European Patent Bulletin, any person may give notice to the European Patent Office of opposition to that patent, in accordance with the Implementing Regulations. Notice of opposition shall not be deemed to have been filed until the opposition fee has been paid. (Art. 99(1) European Patent Convention).